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Dkt. 2271/53467-A1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Reissue Application of: Shunichi SATO

Reissue Application No.: 10/603,418

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Original Patent No.: 5,904,549

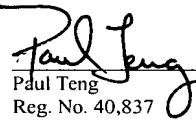
Granted On: May 18, 1999

For: METHODS FOR GROWING SEMICONDUCTORS AND DEVICES THEREOF  
FROM THE ALLOY SEMICONDUCTOR GAINNAS

Examiner: Laura M. Schillinger

Group Art Unit: 2813

I hereby certify that this correspondence is being deposited this date with the U.S. Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

  
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Reg. No. 40,837

June 23, 2005  
Date

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Mail Stop Amendment  
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Sir:

**AMENDMENT**

This Amendment is submitted in response to the Office Action dated March 23, 2005 in connection with the above-identified application.

Amendments to the claims are reflected in the **Listing of Claims** section which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.

A copy of the Ohkouchi paper is attached hereto as **Exhibit A**.

A Form PTO-1449 is attached hereto as **Exhibit B**.